

Electronic Patent Application Fee Transmittal

Application Number:	10812354			
Filing Date:	30-Mar-2004			
Title of Invention:	Method of improving the wafer to wafer uniformity and defectivity of a deposited dielectric film			
First Named Inventor/Applicant Name:	Noriaki Fukiage			
Filer:	James Klekotka			
Attorney Docket Number:	071469-0308969 (FKL-020)			
Filed as Large Entity				
Utility under 35 USC 111(a) Filing Fees				
Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Extension-of-Time:				
Extension - 1 month with \$0 paid	1251	1	130	130

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Miscellaneous:				
Total in USD (\$)				130